

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang et. al.

Serial No.: Not Yet Assigned

Filed: July 14, 2003

For: SEMICONDUCTOR FUSES,
METHODS OF USING AND MAKING
THE SAME, AND SEMICONDUCTOR
DEVICES CONTAINING THE SAME

Confirmation No.: Unknown

Examiner: Unknown

Group Art Unit: Unknown

Attorney Docket No.: 2269-3541.3US
(97-0855.03/US)

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present application is a divisional of application Serial No. 10/331,033, filed December 27, 2002, pending, which is a continuation of application Serial No. 09/901,761, filed July 9, 2001, now U.S. Patent 6,511,868, issued January 28, 2003, which is a continuation of application Serial No. 09/165,754, filed October 2, 1998, now U.S. Patent 6,277,674, issued August 21, 2001.

Pursuant to M.P.E.P. 2001.06(b), the Examiner is respectfully requested to consider the information of record in the three prior applications, and to confirm in the first Office Action on

Attorney Docket No. 2269-3541.3US

the merits that such art has in fact been reviewed. A PTO-1449 or PTO/SB/08 form listing all of the information of record in the prior applications is enclosed herewith.

This Information Disclosure Statement is filed within three (3) months of the filing date of the above-identified application, and no certification pursuant to 37 C.F.R. § 1.97(c) or a fee pursuant to 37 C.F.R. 1.17(p) is required.

Respectfully submitted,



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KWP/dlm:ljb

Enclosures: Form PTO-1449 or PTO/SB/08

Document in ProLaw

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>			Docket Number (Optional) 3541.3US (97-0855.03/US)		Application Number Not Yet Assigned	
			Applicant Wang et al.			
			Filing Date July 14, 2003		Group Art Unit Unknown	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,491,860	01/1985	Lim			
	4,740,485	04/1988	Sharpe-Geisler			
	4,783,424	04/1997	Ohno et al.			
	4,796,075	01/1989	Whitten			
	5,589,706	12/1996	Mitwalsky et al.			
	5,618,750	04/1997	Fujuhara et al.			
	5,625,218	04/1997	Yamadera et al.			
	5,914,524	06/1999	Komenaka			
	5,990,537	11/1999	Endo et al.			
	6,277,674 B1	08/2001	Wang et al.			

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
		Fukuda, Yukio, et al., <u>A New Fusible-Type Programmable Element Composed of Aluminum and Polysilicon</u> . IEEE Transactions on Electron Devices, Vol. ED-33, No. 2, Feb. 1986.

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance not considered. Include copy of this form with next communication to the applicant.